

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
KURATAKA, NOBUO, et al. :
Serial No.: Unassigned : Group Art Unit: Unassigned
Filed: Concurrently Herewith : Examiner: Unassigned
For: METHOD FOR PROTECTING SURFACE OF STAMPER/IMPRINTER
DURING MANUFACTURE THEREOF

APPLICATION DATA SHEET

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following inventor bibliographic information is submitted in accordance with
the provisions of 37 CFR 1.76 and MPEP 6 01.05.

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